

ITD

PATENT



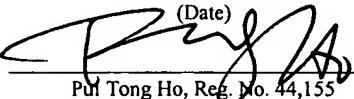
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jason A. Graetz, et al.
App. No. : 10/660,382
Filed : September 10, 2003
For : HIGH-CAPACITY
NANOSTRUCTURED SILICON
AND LITHIUM ALLOYS
THEREOF
Examiner : Laura S. Weiner

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 8, 2005

(Date)


Pui Tong Ho, Reg. No. 44,155

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

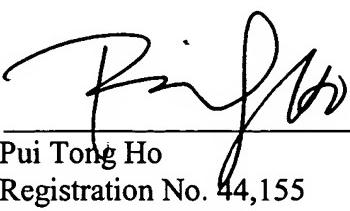
Our file for the subject application reveals that there has been no action in this application since the Assignment was recorded on February 5, 2004.

Please inform us as to the status of this application.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: April 8, 2005

By: 

Pui Tong Ho
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Attorney of Record
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